



00862.022205.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Yoshiyuki NAGAI et al.)	Examiner: M. Landau
Application No.: 09/839,139)	Group Art Unit: 2815
Filed: April 23, 2001)	Confirmation No.: 1616
For: LASER OSCILLATION APPARATUS, EXPOSURE)	April 14, 2004
APPARATUS, SEMICONDUCTOR DEVICE)	
MANUFACTURING METHOD, SEMICONDUCTOR)	
MANUFACTURING FACTORY, AND EXPOSURE)	
APPARATUS MAINTENANCE METHOD)	

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated January 14, 2004, please amend the above-identified application as follows: